## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	YOUNG HOON PARK, ET AL.	) Group Art Unit: NYA
		)
For:	METHOD OF DEPOSITING THIN FILM	) Examiner: NYA
	USING HAFNIUM COMPOUND	)

## **CLAIM FOR PRIORITY**

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants hereby claim the benefit of the filing date of November 12, 2002 to Korean Application No. 2002-70054 under provisions of 35 U.S.C. 119 and the International Convention for the protection of Industrial Property.

If any fees are due with regard to this claim for priority, please charge them to Deposit Account No. 06-1130 maintained by Applicant's attorneys.

I certify that this correspondence is being deposited with the United States Postal Service as Express mail in an envelope addressed to:

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Respectfully submitted,

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